



IFW  
PATENT  
8053-1015

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Takekazu TANAKA

Conf. 1342

Application No. 10/602,044

Group 2814

Filed June 24, 2003

Examiner A. Chambliss

SEMICONDUCTOR PACKAGE, AND PRODUCTION  
PROCESS FOR MANUFACTURING SUCH SEMICONDUCTOR  
PACKAGE

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying document, a copy of which is attached to this statement, is made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of this item is that this reference was cited by the Japanese Patent Office in an Official Action. A copy of the Japanese Official Action in which it was cited is attached hereto, with what is believed to be the pertinent portion enclosed in a wavy line. **An English translation of the enclosed portion is also attached hereto.** JP 2000-114445 was previously cited in the Information Disclosure Statement filed March 21, 2005.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information con-

tained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON



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Robert J. Patch, Reg. No. 17,355  
745 South 23<sup>rd</sup> Street  
Arlington, VA 22202  
Telephone (703) 521-2297  
Telefax (703) 685-0573  
(703) 979-4709

RJP/lk

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**8053-1015**

Application No.:  
**10/602,044**

Applicant:  
**Takekazu TANAKA**

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Group Art Unit:  
**2814**

(Use several sheets if necessary)

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER:

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience